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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-210159 07/18/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <u>Examiner's Signature</u> Initials	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 11	TOTAL  CLAIMS 15	INDEPENDENT  CLAIMS 2
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## TITLE

Electron beam exposure apparatus and semiconductor device manufacturing method

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